

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Inventor(s) : Franz LAERMER et al.  
Serial No. : 10/524,610  
Filed : August 11, 2005  
For : LAYER SYSTEM HAVING A SILICON LAYER AND A  
PASSIVATION LAYER, METHOD FOR CREATING A  
PASSIVATION LAYER ON A SILICON LAYER AND ITS  
USE  
Examiner : Hoang Ho  
Art Unit : 2818  
Confirmation No. : 9981

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, Virginia 22313-1450

I hereby certify that this correspondence is being electronically  
deposited to the USPTO via the Office electronic filing system on

Date: May 10, 2010

Signature: /Kevin Kambo/  
Kevin Kambo

**RESPONSE TO NOTICE OF NON-COMPLIANT AMENDMENT**

S I R:

In response to the Notice of Non-Compliant Amendment dated  
April 27, 2010 in connection with the above-captioned application, Applicants submit  
herewith a corrected "Amendments to the Claims" section, which begins on page 3  
of this paper.

It is respectfully submitted that all issues raised in the Notice of  
Non-Compliant Amendment have been obviated, and reconsideration is respectfully  
requested.

While no fees are believed to be due, the Commissioner is authorized,  
as appropriate and/or necessary, to charge any fees or credit any overpayment to  
**Deposit Account No. 11-0600.**

This submission contains only the corrected "Amendments to the  
Claims" section, as is permitted by 37 C.F.R. 1.121. For the substantive remarks on  
the Office Action, please refer to the prior Amendment dated April 7, 2010. It is  
respectfully submitted that the subject matter of the present application is new, non-